

Form PTO-1449		ATTY DOCKET NO. 20-4652P	APPLICATION NO. 09/471,173			
INFORMATION DISCLOSURE CITATION IN AN APPLICATION (Use several sheets if necessary)		APPLICANT Narihiro MOROSAWA et al.				
		FILING DATE December 22, 1999	GROUP Not Assigned			
U.S. PATENT DOCUMENTS						
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
FOREIGN PATENT DOCUMENTS						
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	TRANSLATION
						YES
<i>JZ</i>	HEI 5-082777 Japanese Patent Laid-Open Publication	4/2/93	JAPAN			ABST.
<i>JZ</i>	HEI 5-074762 Japanese Patent Laid-Open Publication	3/26/93	JAPAN			ABST.
<i>JZ</i>	HEI 5-283679 Japanese Patent Laid-Open Publication	10/29/93	JAPAN			ABST.
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)						
<i>JZ</i>	"Effects of boron penetration and resultant limitations in ultra thin pure-oxide and nitrided-oxide gate-films", Toyota Morimoto et al., <u>IEDM</u> , pp. 429-432, 1990.					
	"CMOS Technology Scaling, 0.1µm And Beyond", Bijan Davari, <u>IEDM</u> , pp. 555-558, 1996.					
	"Analysis of an ONO gate film effect on n- and p-MOSFET mobilities", H. Iwai et al., <u>1990 Symposium on VLSI Technology</u> , pp. 131-132.					
	"Hot-Electron Hardened Si-Gate MOSFET Utilizing F Implantation", Yasuhiro Nishioka, et al., <u>IEEE Electron Device Letters</u> , Vo. 10, No. 4, pp. 141-143, April 1989.					
EXAMINER <i>Kevin Quinto</i>		DATE CONSIDERED <i>3/22/01</i>				
EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.						

FTB

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INFORMATION DISCLOSURE CITATION IN AN APPLICATION <small>(Use several sheets if necessary)</small>		APPLICANT Narihiro MOROSAWA et al.				
		FILING DATE December 23, 1999	GROUP 2811			
U.S. PATENT DOCUMENTS						
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
<i>KL</i>	6,018,182	01/25/2000	Morosawa			
FOREIGN PATENT DOCUMENTS						
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	TRANSLATION
						YES
OTHER DOCUMENTS <small>(Including Author, Title, Date, Pertinent Pages, etc.)</small>						
EXAMINER	<i>Ken Dubois</i>					
DATE CONSIDERED	<i>3/22/01</i>					

EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

DJD:kna